

SLT 2020 Advance Program, Tuesday, 16.6.2020

08:15 - 09:00	Registration and Coffee								
---------------	--------------------------------	--	--	--	--	--	--	--	--

Room C1.2.2: Plenary Session

<i>Plenary Session</i>			<i>Chair T. Graf</i>						
09:00 - 09:10	H. Götz	SLT Opening and Information	SLT Organization, IFSW, Universität Stuttgart, Germany						
09:10 - 09:20	T. Graf	Welcome to the SLT 2020	IFSW, Universität Stuttgart, Germany						
09:20 - 09:30	E. Kerwien	Women in Photonics	Photonics BW, Stuttgart, Germany						
09:30 - 10:00	C. Schmitz	Industrial Laser Processing: What's next?	TRUMPF Lasertechnik GmbH, Ditzingen, Germany						
10:00 - 10:30	C. Häfner	N.N.	Fraunhofer ILT Aachen, Germany						

10:30 - 11:15

Coffee and Cookies

10:30 - 11:15

Coffee and Cookies
Room C1.2.1: Fundamentals and Applications of CW Laser Processing

<i>Process Improvement with Shaped Laser Beams</i>			<i>Chair R. Weber</i>
11:15 - 11:40	T. Hesse/Speker	Copper Welding with Green Wavelength in the kW Laser Power Class	TRUMPF GmbH, Ditzingen, Germany
11:40 - 12:05	J. Lind	Insight into the Laser Cutting Process	IFSW + Precitec, Germany
12:05 - 12:30	A. Wetzig	Fast beam oscillations improve laser cutting of thick materials	Fraunhofer IWS, Dresden, Germany

12:30 - 14:15

Lunch and LASYS visit

<i>Process Control for Additive Manufacturing and Welding</i>			<i>Chair C. Hagenlocher</i>
14:15 - 14:40	M. Kogel-Hollacher	OCT in additive manufacturing	Precitec GmbH & Co. KG, Gaggenau, Germany
14:40 - 15:05	T. Seefeld	Prozessüberwachung bei der additiven Fertigung	BIAS - Bremer Institut für angewandte Strahltechnik GmbH, Bremen, Germany
15:05 - 15:30	C. Franz	Laser Welding Monitoring and Control	4D GmbH, Isernhagen, Germany

15:30 - 16:10

Coffee and Cookies

<i>Process Fundamentals of Additive Manufacturing and Welding</i>			<i>Chair T. Graf</i>
16:10 - 16:35	B. Simonds	Experimental Advances in Dynamic Laser Coupling Measurements on Metals - From Solids to Powders	NIST, Boulder, USA
16:35 - 17:00	A. Otto	Numerical modelling of powder bed processes	LPT, Universität Wien, Austria
17:00 - 17:25	P. Berger	Looking back - Process Fundamentals Over the Years-	IFSW, Universität Stuttgart, Germany

17:25

18:00 - 18:30		Individual transfer to IFSW							
18:30 - 18:45	T. Graf	SLT-Evening Welcome	IFSW, Universität Stuttgart, Germany						
18:45 - 19:30	IFSW Staff	Laser Application Basics Live							
19:30 - 22:00		Networking and dinner in the inner courtyard							
22:00		Official end of evening							

Program subject to change without notice

Room C1.2.2: Ultrafast Laser Sources and Optics

<i>High-Power and High-Energy Ultrafast Lasers</i>			<i>Chair M. Abdou Ahmed</i>
11:15 - 11:40	A. Killi	Industrial high power lasers covering ns to fs regime	TRUMPF Laser- und Systemtechnik GmbH, Schramberg, Germany
11:40 - 12:05	C. Röcker	Generation of high-power Green and UV ultra-short pulses (TBD)	IFSW, Stuttgart, Germany
12:05 - 12:30	M. Smrz	TRL 8 laser manufacturing station for multibeam processing	HiLASE, Praha, Czech Republic

12:30 - 14:15

Lunch and LASYS visit

<i>Novel Laser and Beam Delivery Concepts</i>			<i>Chair M. Abdou Ahmed</i>
14:15 - 14:40	É. Audouard	New microstructured optical fibers for innovative lasers and beam transportation	Amplitude Système, Pessac, France
14:40 - 15:05	C. Röhrer	Propagation of high-brightness laser beams in highly multimode fibers	IFSW, Stuttgart, Germany
15:05 - 15:30	C. Gaida	Thulium-doped, ultrafast fiberlasers: from a laboratory curiosity to a top-performer	Active Fiber Systems GmbH, Jena, Germany

15:30 - 16:10

Coffee and Cookies

<i>Holistic Approach to Ultrafast Laser Processing Systems</i>			<i>Chair V. Onuseit</i>
16:10 - 16:35	A. Loescher	kW-ps thin-disk laser for high throughput manufacturing	IFSW, Universität Stuttgart, Germany
16:35 - 17:00	A. Peter	Automated free-space beam delivery system for ultrafast laser beams in the kW regime	IFSW, Universität Stuttgart, Germany
17:00 - 17:25	D. Holder	From Drilling to Surface Structuring: kW-Class Laser Applications	IFSW, Universität Stuttgart, Germany

17:25

18:00 - 18:30									
18:30 - 18:45	T. Graf	SLT-Evening Welcome	IFSW, Universität Stuttgart, Germany						
18:45 - 19:30	IFSW Staff	Laser Application Basics Live							
19:30 - 22:00		Networking and dinner in the inner courtyard							
22:00		Official end of evening							

Program subject to change without notice

SLT 2020 Advance Program, Wednesday, 17.6.2020

08:15 - 09:00	Registration and Coffee
---------------	--------------------------------

Room C1.2.2: Plenary Session

<i>Plenary Session</i>			<i>Chair T. Graf</i>					
09:00 - 09:05	H. Götz	SLT Opening and Information	SLT Organization, IFSW, Universität Stuttgart, Germany					
09:05 - 09:30	L. Overmeyer	Einstein Elevator	Leibnitz Universität Hannover, Hannover, Germany					
09:30 - 10:00	W. Kaiser	Technology development and outlook for the future of lithography	Carl Zeiss SMT GmbH, Oberkochen, Germany					
10:00 - 10:30	T. Graf	Laser Processing Today and Tomorrow	IFSW, Universität Stuttgart, Germany					

 10:30 - 11:15 **Coffee and Cookies**

 10:30 - 11:15 **Coffee and Cookies**
Room C1.2.1: Fundamentals and Applications of Ultrafast Laser Processing

<i>Spatial and Temporal Optimization of Ultrafast Laser Processes</i>			<i>Chair A. Feuer</i>
11:15 - 11:40	B. Neuenschwander	System technology for processing with high power ultrafast lasers	Berner FH, Burgdorf, Switzerland
11:40 - 12:05	A. Koglbauer	Scaling ultra-short laser processing for thick glass	Schott AG, Mainz, Germany
12:05 - 12:30	A. Michalowski	Temporally Optimized USP Laser Processes	Robert Bosch GmbH, Stuttgart, Germany

 12:30 - 14:15 **Lunch and LASYS visit**

<i>Special Systems for High-Precision Laser Drilling</i>			<i>Chair V. Onuseit</i>
14:15 - 14:40	R. Holtz	Ultrafast Helical Drilling Optic	Fachhochschule Nordwestschweiz, Windisch, Switzerland
14:40 - 15:05	H. Schlüter	5-Axis Scan Head for High Precision Drilling	SCANLAB GmbH, Puchheim, Germany
15:05 - 15:30	D. Brinkmeier	Optic Concept for High Power Helical Drilling	IFSW, Universität Stuttgart, Germany

 15:30 - 16:10 **Coffee and Cookies**

<i>Focus on X-Rays from Ultrafast Laser Processing</i>			<i>Chair R. Weber</i>
16:00 - 16:10	R. Weber	Introduction to the USP-X-Ray Session	IFSW, Universität Stuttgart, Germany
16:10 - 16:25	B. Hahn	The Current Legal Situation for Ultrashort Pulse Laser Material Processing Operations (USPL)	Ministerium für Energie BW, Heilbronn, Germany
16:25 - 16:40	C. Freitag	USP-X-Ray Emission Protection in Industrial Production Environment	LightPulse LASER PRECISION, Stuttgart, Germany
16:40 - 16:55	R. Giedl-Wagner	X-Ray Emission During Laser Turning with Ultra-Short Pulses	GFH GmbH, Deggendorf, Germany
16:55 - 17:15	G. Kunz	X-Ray Emission from Industrial Applications with Ultra-Short Laser Pulses	Robert Bosch GmbH, Stuttgart, Germany
17:15 - 17:20	R. Weber	SLT 2020 Closing Note	IFSW, Universität Stuttgart, Stuttgart, Germany

17:20 Program subject to change without notice

Room C1.2.2: High Average Power CW Laser Sources and Optics

<i>Dynamic Path Planning for Laser Machining</i>		<i>Chair V. Onuseit</i>
11:15 - 11:40	A. Verl	Real time path planning and process control for additive manufacturing
11:40 - 12:05	R. Beccard	oolpath Planning in Laser Metal Deposition Processes for Complex 3D Geometries
12:05 - 12:30	M. Buser	Dynamic path planning for depth controlled laser ablation

 12:30 - 14:15 **Lunch and LASYS visit**

<i>Laser Beam Tailoring</i>		<i>Chair M. Abdou Ahmed</i>
14:15 - 14:40	M. Hana	1D nonlinear optics in multipass cells
14:40 - 15:05	G. Pallier	TBC: MPLC systems for high-power CW and fs laser beams
15:05 - 15:30	M. Rumpel	Latest results on Resonant Grating Mirrors for High-Power Lasers

 15:30 - 16:10 **Coffee and Cookies**

<i>Intelligent Laser and Processing Systems</i>		<i>Chair V. Onuseit</i>
16:00 - 16:25	A. Patschger	In process defect detection in additive manufacturing through image-supported machine learning
16:25 - 16:50	T. Grünberger	Machine learning for process monitoring systems based on examples from laser materials processing to additive manufacturing
16:50 - 17:15	K. Schmidt	Methods for controlling adaptive optical systems in high power resonators
17:15 - 17:20	V. Onuseit	SLT 2020 Closing Note

17:20 Program subject to change without notice